

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: ) Confirmation No.: 2500  
Koichiro TANAKA et al. ) Examiner: Sang Y. Paik  
Serial No. 10/586,048 ) Group Art Unit: 3742  
Filed: July 14, 2006 )  
For: LASER IRRADIATION APPARATUS )  
AND LASER IRRADIATION METHOD )

**AMENDMENT**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.